

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Osamu MATSUURA, et al.

Serial Number: Not Yet Assigned

Filed: December 24, 2003

Customer No.: 38834

For: FERROELECTRIC CAPACITOR, PROCESS FOR PRODUCTION THEREOF AND
SEMICONDUCTOR DEVICE USING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

December 24, 2003


Sir:

In compliance with 37 CFR 1.56, Applicant(s) call(s) to the attention of the Patent and
Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge
Deposit Account No. 50-2866.

Respectfully submitted,
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Enclosures: PTO-1449; References (7)

INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 032203	Serial No. New Appln.
	Applicant(s): Osamu MATSUURA, et al.	
	Filing Date: December 24, 2003	Group Art Unit:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)
_____ AE 6-68529	03/11/94	Japan	Abstract
_____ AF 6-280023	10/04/94	Japan	Abstract
_____ AG 8-31951	02/02/96	Japan	Abstract
_____ AH 2000-40799	02/08/00	Japan	Abstract
_____ AI 2000-232102	08/22/00	Japan	Abstract
_____ AJ 2001-284549	10/12/01	Japan	Abstract
_____ AK 2002-16234	01/18/02	Japan	Abstract

OTHER DOCUMENTS

_____	AL	
_____	AM	
Examiner		Date Considered